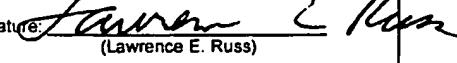


I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as First Class Mail, in an envelope addressed to: MS AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Dated: August 2, 2006

Signature: 
(Lawrence E. Russ)

EXPEDITED PROCEDURE

Group Art Unit: 2811

Docket No.: VELOX 3.0-001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: :
Pohristic et al. :
Application No.: 10/780,526 : Group Art Unit: 2811
: :
: Filed: February 17, 2004 : Examiner: S. A.
: : Gebremariam
: :
: For: LOW DOPED LAYER FOR NITRIDE- :
: BASED SEMICONDUCTOR DEVICE :

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 CFR 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated May 3, 2006, finally rejecting claims 1-17, 19-36, and 71-73, please amend the above-identified U.S. patent application as follows: